TC 1700

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Annette Crevasse, et al.

Serial No.:

10/061,542

Filed:

October 25, 2001

For:

SYSTEM AND METHOD OF DETERMINING A POLISHING

ENDPOINT BY MONITORING SIGNAL INTENSITY

Group No.:

1765

Examiner:

Tran, Binh X.

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

prespondence is being deposited with the United States Postal Service as addressed to: Commissioner for Patents, Alexandria, VA 22313, on

Sir:

REQUEST FOR RECONSIDERATION OF EXAMINER'S ACTION

The Applicants have carefully considered this application in connection with the Examiner's Action dated May 2, 2003 and respectfully request reconsideration of this application in view of the following remarks.

The Applicants originally submitted Claims 1-21 in the application. The Applicants previously canceled Claims 1-7, 10 and 18 and have not amended or added any claims. Accordingly, Claims 8-9, 11-17 and 19-21 are currently pending in the application.